Silicon Nanotechnology Aiming at Large Scale Integration



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Silicon-Based Integrated Devices

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## **Semiconductors: for Further Developments**

Semiconductor VLSI (very large scale integration) is the basis of contemporary advanced IT society. Hiramoto/Kobayashi Lab. aims at solving worldwide problems by the technological innovation of future integrated nanoelectronics from the device side. Based on the vision in Fig. A, we are pursuing the extreme form of integrated nanodevices. For Japan's semiconductor industry restoration, Prof. Hiramoto joined Leading-edge Semiconductor Technology Center (LSTC) and Prof. Kobayashi participated in Rapidus Corporation.



Fig. A. A vision map of the integrated nanoelectronics, drawn by Prof. Hiramoto in Semiconductor Technology Roadmap Committee of Japan (STRJ). A new field of "Extended CMOS" will be created by integrating "Beyond CMOS" and "More Than Moore" into CMOS base technology. This map is found in International Technology Roadmap for Semiconductor (ITRS).

